



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of  
Thomas Juestel et al

Group Art Unit: 2841

Application No. 09/852,166

Examiner: Thanh S Phan

Filed: May 9, 2001

Atty. Docket PHDE000075

For: Rare-gas low-pressure discharge  
lamp, method of manufacturing a  
rare-gas low-pressure discharge

AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as first  
class mail in an envelope addressed to Assistant  
Commissioner for Patents, Washington, D.C. 20231

On: Nov. 20, 2002

By: John C. Fox

In response to the Office action dated August 28, 2002,  
please amend the subject application as follows and reconsider the  
application in light of the following remarks.

In the Specification:

On page 1, after the title and before line 1, please  
insert the following heading:

9/24 2841

#7/Andt A  
R2  
11/27/02

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